

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)**

Applicant(s): Byung Chul CHO, et al.

Docket No.

YPL-0070

Application No.

10/748,098

Filing Date

12-30-2003

Examiner

Zervigon, Rudy

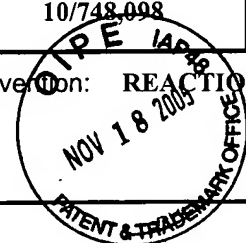
Customer No.

23413

Group Art Unit

1763

Invention: REACTION CHAMBER FOR DEPOSITING THIN FILM



I hereby certify that this Amendment Transmittal Letter (1 page), Amendment (10 pages), Replacement Drawings (2 Sheets), Declaration Under 37 CFR 1.131 (2 pages), Verified English Translation of Korean Application No. 10-2003-0000365 (27 pages) and Postcard  
(Identify type of correspondence)

is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on  
November 16, 2005  
(Date)

Tammie Lanthier

(Typed or Printed Name of Person Mailing Correspondence)

(Signature of Person Mailing Correspondence)

Note: Each paper must have its own certificate of mailing.